

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant(s): Yuanning Chen, et al.

Art Unit: 2813

Division of Serial No.: 10/294,265

Examiner: Jack S J Chen

Filed: Herewith

Docket: TI-35022.2

For: Use of Hafnium Silicon Oxynitride as the Cap Layer of the Sidewall Spacer

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*Karen Vertz*  
Karen Vertz

*11-21-03*  
Date

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**PRELIMINARY AMENDMENT**

Dear Sir:

Prior to the examination of the above-identified application, please amend as follows:

**IN THE SPECIFICATION:**

Please amend the Specification by inserting before the first line the following sentence:

--This is a division of Application No. 10/294,265, filed 11/14/2002, the entire disclosure of which is hereby incorporated by reference--.